



Attorney's Docket No.: 10417-006001 / S21-118827M/HW

GP- 2814

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shuichi Kikuchi et al.
Serial No. : 09/444,819
Filed : November 22, 1999
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE
SAME

Art Unit : Unknown
Examiner : Unknown

Assistant Commissioner for Patents
Washington, D.C. 20231

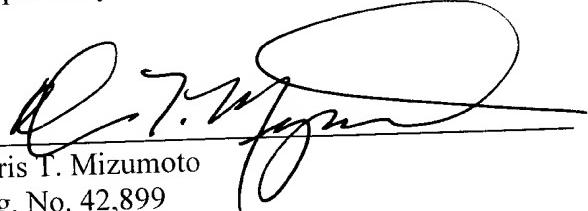
INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449, copies of which are enclosed.

This statement is being filed within three months of the filing date of the application or before the receipt of a first Office action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 2/18/00


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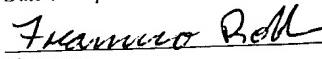
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February 18, 2000

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Francisco Robles

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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 10417-006001	Application No. 09/444,819
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Shuichi Kikuchi et al.	RECEIVED
		Filing Date November 22, 1999	Group Art UFFR 28 2000
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U.S. Patent Documents

Examiner Initial	Desig. ID	Patent & Trademark Office Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation Yes No
	AL	JPA-09-139438	May 27, 1997	Japan	H01L	21/8249	x
	AM						
	AN						
	AO						
	AP						

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	